IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Torbjörn Ling et al.) Group Art Unit: 1791
Application No. 10/518,475) Examiner: Luk, Emmanuel S.
Filed: December 20, 2004) Confirmation No. 3599
For: MOLD FOR NANO IMPRINTING)
Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	

REQUEST FOR RECONSIDERATION

In reply to the Office Action mailed December 23, 2008, with a period for response extending through March 23, 2009, Applicants request the Examiner's reconsideration in view of the remarks that follow:

Remarks begin on page 2 of this paper.

Sir: